Applicant: Johannes Baur et al. Attorney's Docket No.: 12406-118US1 / P2001,0176

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Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

 (Currently amended) A radiation-emitting semiconductor component, comprising:

a multilayer structure including an active layer for generating radiation in said multilayer structure;

electrical contacts connected to said active layer;

a radiation-transmissive window with a first main surface adjoining said multilayer structure and a second main surface opposite said first main surface;

said second main surface having at least one void selected from the group consisting of a trench recess and a pit recess formed therein for increasing a coupling-out of radiation from said window through said void wherein said void extends only partially through said window.

- (Original) The semiconductor component according to claim 1, wherein said window is formed with side surfaces perpendicular to said first and second main surfaces.
- (Original) The semiconductor component according to claim 1, wherein said window is formed with side surfaces having partial regions orthogonal to said first and second main surfaces.
- (Original) The semiconductor component according to claim 1, wherein said window has an enveloping basic shape selected from the group consisting of parallelepiped shapes and cuboid shapes.

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 (Original) The semiconductor component according to claim 1, wherein said void has at least one planar side surface enclosing an angle different from 90° with said second main surface.

- (Original) The semiconductor component according to claim 5, wherein said angle is between 20° and 70°.
- (Original) The semiconductor component according to claim 1, wherein said void
 has a bottom surface substantially parallel to said second main surface.
- (Original) The semiconductor component according to claim 1, wherein said void is a trench recess formed with a triangular or trapezoidal cross section tapering toward said first main surface.
- (Original) The semiconductor component according to claim 1, wherein said at least one void is one of a plurality of trench recesses formed in said window.
- (Original) The semiconductor component according to claim 1, wherein said void is bounded by at least one curved surface.
- 11. (Original) The semiconductor component according to claim 10, wherein said void has a form substantially describing a hemisphere, a sphere segment, an ellipsoid segment, a cone, or a truncated cone.
- (Original) The semiconductor component according to claim 1, wherein said window has a refractive index greater than a refractive index of said multilayer structure.
- (Original) The semiconductor component according to claim 1, wherein said window contains a material selected from the group consisting of sapphire, quartz glass, diamond, ITO, SnO, ZnO, InO, SiC, and GaP.

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 (Original) The semiconductor component according to claim 1, wherein said multilaver structure is based on GaN.

- 15. (Original) The semiconductor component according to claim 14, wherein said multilayer structure contains at least one gallium compound selected from the group consisting of GaN, $Al_{1x}Ga_xN$ ($0 \le x \le 1$), $In_{1x}Ga_xN$ ($0 \le x \le 1$), and $Al_{1x}Jin_xGa_xN$ ($0 \le x \le 1$), ($0 \le x \le 1$).
- (Original) The semiconductor component according to claim 1, wherein said multilayer structure is an epitaxy product.
- 17. (Original) The semiconductor component according to claim 16, wherein said multilayer structure is deposited on an epitaxial substrate and said window is produced from said epitaxial substrate.
- (Original) The semiconductor component according to claim 1, wherein said window is connected to said multilayer structure by a wafer bonding process.
- 19. (Previously Presented) A method for producing a semiconductor component, the method which comprises the following steps: providing a window layer having a first main surface and a second main surface opposite the first main surface; applying a semiconductor layer sequence to the first main surface of the window layer; forming at least one recess in the second main surface of the window layer; and completing the semiconductor component according to claim 1.
- (Original) The method according to claim 19, which comprises depositing the semiconductor layer sequence on the window layer by epitaxy.
- (Original) The method according to claim 19, which comprises applying the semiconductor layer sequence to the window layer in a wafer bonding process.

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 (Original) The method according to claim 19, which comprises forming the recess by sawing into the window layer on the second main surface.

- (Original) The method according to claim 22, which comprises sawing with a saw blade having a shaping edge.
- (Original) The method according to claim 23, which comprises sawing with a saw blade having a trapezoidal cross section in a sawing region.
- (Original) The method according to claim 19, which comprises etching the recess into the second main surface.
- (Original) The method according to claim 19, which comprises forming the recess with a laser ablation process.
 - (Cancelled)
- (New) A radiation-emitting semiconductor component, comprising:
 a multilayer structure including an active layer for generating radiation in said multilayer structure;

electrical contacts connected to said active layer;

a radiation-transmissive window with a first main surface adjoining said multilayer structure and a second main surface opposite said first main surface;

said second main surface having at least one void selected from the group consisting of a trench recess and a pit recess formed therein for increasing a coupling-out of radiation from said window, wherein said void has at least one planar side surface enclosing an angle between 20° and 70° with said second main surface.